



#14/IDS
Sub
12/27/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/881,407
Confirmation No. None
Filing Date June 13, 2001
Inventor Zhongze Wang
Assignee Micron Technology, Inc.
Group Art Unit 2822
Examiner Perkins, Pamela E.
Attorney's Docket No. MI22-1670
Customer No. 21567
Title: Methods of Forming Transistor Devices

INFORMATION DISCLOSURE STATEMENT

References –See Attached Form PTO-1449

The Examiner's attention is directed to the reference which is listed on the attached Form PTO-1449, a copy of which is attached. No admission is made regarding whether the submitted reference is prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 10/17/03

By: [Signature]
Robert C. Hyta
Reg. No. 46,791

EV317134702